

U.S. PTO
12/23/01

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10023948	FILING DATE 12/21/2001	CLASS 252	SUBCLASS -	GAU 135 1763	EXAMINER J. M. Eran...
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**APPLICANTS: Lee Jae-dong; Yoon Bc-un; Hah Sang-rok;

**CONTINUING DATA VERIFIED: none

** FOREIGN APPLICATIONS VERIFIED: verify
REPUBLIC OF KOREA 2000-80715 12/22/2000

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed

☒ yes ☐ no

35 USC 115 conditions met

☒ yes ☐ no

Verified and Acknowledged Examiners's initials

LGW-E

ATTORNEY DOCKET NO

SEC.861

TITLE : Chemical mechanical polishing slurry

U.S. DEPT. OF COM. / PAT & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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